

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: Y. KAWAMURA et al
Serial No. 09/754,193
Filed: January 5, 2001

Group Art: 3723
Examiner: M. Rachuba
For: METHOD FOR POLISHING SURFACE OF
SEMICONDUCTOR DEVICE SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Mail Stop Patent Application
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, the Applicants inform the Examiner of the documents cited during prosecution of the parent application, USSN 09/754,193.

The Applicants request the Examiner to initial and return a copy of the attached PTO-1449 form as an indication that the references have been considered.

Respectfully submitted,

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Date: September 12, 2003

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. ASA-955-02	SERIAL NO.
LIST OF DOCUMENTS CITED BY APPLICANT <i>(Use several sheets if necessary)</i>		APPLICANT Y. KAWAMURA et al			
		FILING DATE September 12, 2003		GROUP	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE <i>(If Appropriate</i>
	AA 5,486,129	01/1996	Sandhu et al			
	AB 5,643,061	07/1997	Jackson et al			
	AC 5,762,544	06/1998	Zuniga et al			
	AD 5,795,215	08/1998	Guthrie et al			
	AE 6,000,339	12/1999	Matsuzawa, Jun			
	AF 6,093,091	07/2000	Keller, Thomas			
	AG 6,106,379	08/2000	Mosca, Joseph			
	AH 6,113,468	09/2000	Natalicio, John			
	AI 6,241,591	06/2001	Jackson et al			
	AJ 6,251,215	06/2001	Zuniga et al			
	AK 6,267,655	07/2001	Weldon et al			

FOREIGN PATENT DOCUMENTS

	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATIO
						YES NO
AL	10-315125	12/2/98	Japan			<input type="checkbox"/> <input type="checkbox"/>
AM	10-286758	10/27/98	Japan			<input type="checkbox"/> <input type="checkbox"/>
AN	9-267257	10/14/97	Japan			<input type="checkbox"/> <input type="checkbox"/>
AO	6-155286	6/3/94	Japan			<input type="checkbox"/> <input type="checkbox"/>
AP	7-314298	12/5/95	Japan			<input type="checkbox"/> <input type="checkbox"/>

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	AR		
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	AT		

EXAMINER	DATE CONSIDERED
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* EXAMINER INITIAL		DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE (If Appropriate)
	AA	6,316,364	11/2001	Kubo, Akira			
	AB						
	AC						
	AD						
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	AH						
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		DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATIO
							YES NO
	AL	9-117860	5/6/97	Japan			<input type="checkbox"/> <input checked="" type="checkbox"/>
	AM	9-232260	9/5/97	Japan			<input type="checkbox"/> <input checked="" type="checkbox"/>
	AN	11-277417	10/12/99	Japan			<input type="checkbox"/> <input checked="" type="checkbox"/>
	AO	11-163103	6/18/99	Japan			<input type="checkbox"/> <input checked="" type="checkbox"/>
	AP	1148538	10/2991	EP			<input checked="" type="checkbox"/> <input type="checkbox"/>

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EXAMINER	DATE CONSIDERED
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